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APPLICATION NO. FILING DATE FIRST NAMED INVENTOR ATTORNEY DOCKET NO. 09/431,593 11/01/99 UEDA 2271/60617 **EXAMINER** MM91/0424 IVAN S KAVRUKOV WARREN, M COOPER & DUNHAM LLP PAPER NUMBER **ART UNIT** 1185 AVENUE OF THE AMERICAS NEW YORK NY 10036 2815 DATE MAILED: 04/24/01

Please find below and/or attached an Office communication concerning this application or proceeding.

Commissioner of Patents and Trademarks

		Application No.	Applicant(s)	
• Office Action Summary		09/431,593	UEDA, YOSHINORI	
	<i></i>	Examiner	Art Unit	
		Matthew E. Warren	2815	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply				
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 1 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136 (a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). - Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b). Status				
1) 🛛 🛭 F	Responsive to communication(s) filed on <u>01 l</u>	November 1999 .		
2a)□ 1	This action is FINAL . 2b) ☐ Th	nis action is non-final.		
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.			
Disposition of Claims				
4)⊠ Claim(s) <u>1-9</u> is/are pending in the application.				
4a) Of the above claim(s) is/are withdrawn from consideration.				
5) Claim(s) is/are allowed.				
6)☐ Claim(s) is/are rejected.				
7) 🗌 CI	7) Claim(s) is/are objected to.			
8) Claims 1-9 are subject to restriction and/or election requirement.				
Application Papers				
9) The specification is objected to by the Examiner.				
10) The drawing(s) filed on is/are objected to by the Examiner.				
11) 🔲 Th	11) ☐ The proposed drawing correction filed on is: a) ☐ approved b) ☐ disapproved.			
12) The oath or declaration is objected to by the Examiner.				
Priority under 35 U.S.C. ₹ 119				
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. ≸ 119(a)-(d) or (f).				
a) ☐ All b) ☐ Some * c) ☐ None of:				
1.	Certified copies of the priority documents	s have been received.		
2.	2. Certified copies of the priority documents have been received in Application No			
 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 				
14) Acknowledgement is made of a claim for domestic priority under 35 U.S.C. § 119(e).				
14) Acknowledgement is made of a signified asmostic priority and of the e.e. 5 110(e).				
Attachment(s)				
	of References Cited (PTO-892)	18) Interview Summar	ry (PTO-413) Paper No(s)	
16) Notice of Draftsperson's Patent Drawing Review (PTO-948) 17) Information Disclosure Statement(s) (PTO-1449) Paper No(s) 20) Other:				

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DETAILED ACTION

Election/Restrictions

Restriction to one of the following inventions is required under 35 U.S.C. 121:

- Claims 1-8, drawn to a semiconductor device, classified in class 257, subclass 536.
- II. Claim 9, drawn to a method of making a semiconductor, classified in class438, subclass 1+.

The inventions are distinct, each from the other because of the following reasons:

Inventions II and I are related as process of making and product made. The inventions are distinct if either or both of the following can be shown: (1) that the process as claimed can be used to make other and materially different product or (2) that the product as claimed can be made by another and materially different process (MPEP § 806.05(f)). In the instant case, a silicide film could be deposited selectively instead of being formed by annealing a metal layer.

Because these inventions are distinct for the reasons given above and have acquired a separate status in the art as shown by their different classification, restriction for examination purposes as indicated is proper.

Applicant is advised that the reply to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 CFR 1.143).

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Matthew E. Warren whose telephone number is (703) 305-0760. The examiner can normally be reached on Mon-Thurs, and alternating Fri, 9:00-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Eddie Lee can be reached on (703) 308-1690. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 305-3432 for regular communications and (703) 308-7722 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

MEW

April 21, 2001

EDDIE LEE

SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800